

INFORMATION DISCLOSURE CITATION
(Use several sheets if necessary)

Docket Number (Optional)
SEC.736D

Application Number
NEW

Applicant(s)
Ch ung-Hyep Kim et al.

Filing Date
APRIL 13, 2004

Group Art Unit
TO BE ASSIGNED

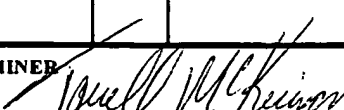
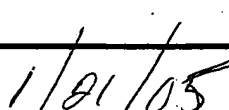
U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<i>TM</i>	A	6,403,933 B1	06/2002	STRODTBECK et al.	/	/	
<i>TM</i>	B	5,778,969	07/1998	KYUNG et al.	/	/	
<i>TM</i>	C	2002/0096117 A1	07/2002	FUTAMURA et al.	/	/	
<i>TM</i>	D	5,981,913	11/1999	KADOMURA et al.	/	/	
<i>TM</i>	E	6,508,885 B1	01/2003	MOSLEHI et al.	/	/	
<i>TM</i>	F	6,449,871 B1	09/2002	KHOLODENKO et al.	/	/	
<i>TM</i>	G	6,185,839 B1	02/2001	KHOLODENKO et al.	/	/	

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
<i>TM</i>	H	6-177141	06/24/1994	JAPAN	/	/		
<i>TM</i>	I	6-181173	06/28/1994	JAPAN	/	/		

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER		
DATE CONSIDERED		

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.